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## **SOCIAL AND LIFE SCIENCES**

**Poltrock S. E., Schwartz D. R., Comparative Judgments of Multidigit Numbers. J Exp Psy L 10(1):32-45, 1984.**

## **ERRATUM**

A. G. Fraser and S. P. Morgan, "Queueing and Framing Disciplines for a Mixture of Data Traffic Types," AT&T Bell Lab. Tech. J., 63, No. 6, Part 2 (July-August 1984), pp. 1061-87.

The illustrations in Figures 6, 7, and 8 in this paper were misplaced. In all cases the captions are correct, but the illustrations are in the wrong positions. The illustration captioned Figure 6 (page 1074) should be Figure 7, Figure 7 (page 1075) should be Figure 8, and Figure 8 (page 1077) should be Figure 6.